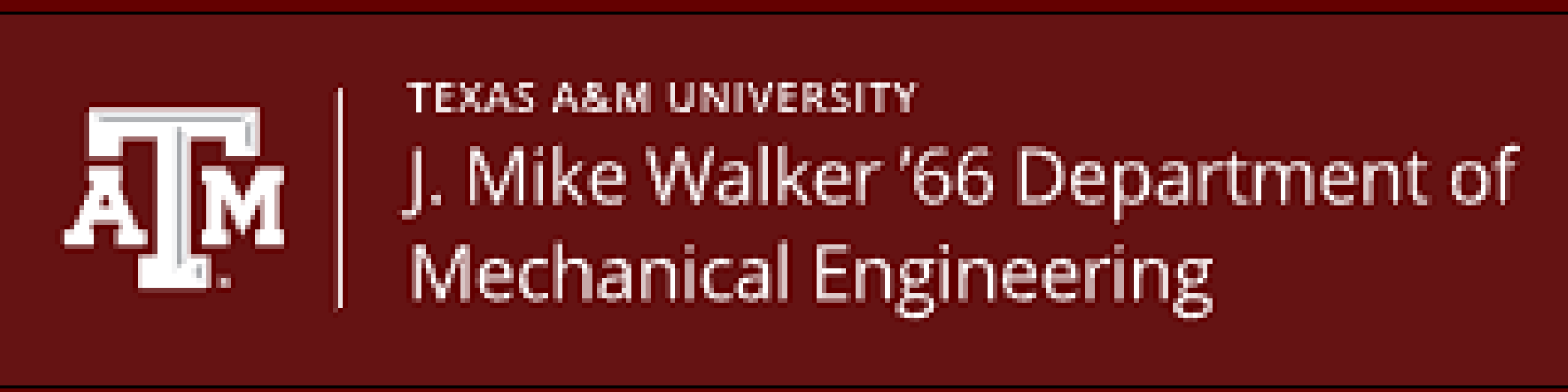


In-Process Cutting Temperature Monitoring Method Based on Impedance Model of Dielectric Coating Layer at Tool-Chip Interface



Dielectric Coating Layer at Tool-Chip Interface

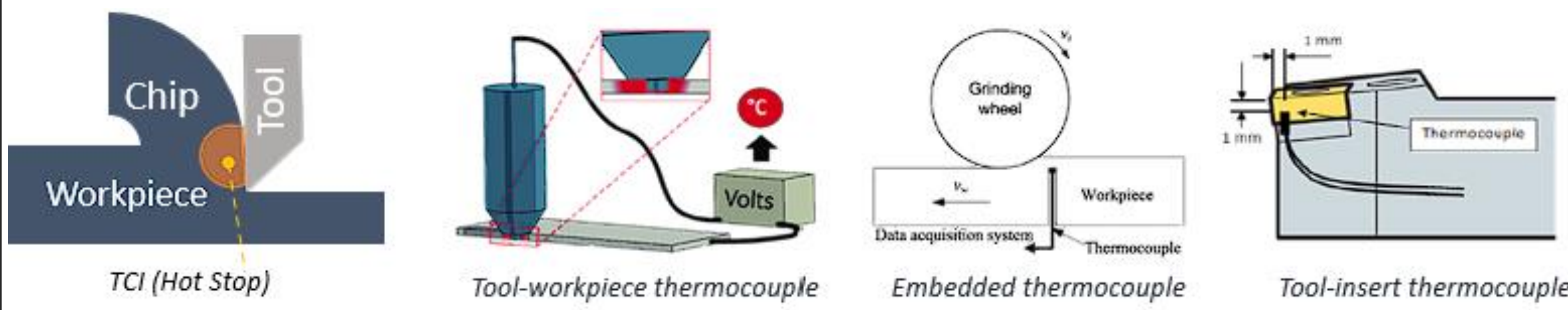
Heebum Chun | **William Park '23** | Jungsub Kim, Ph.D. | ChaBum Lee, Ph.D.



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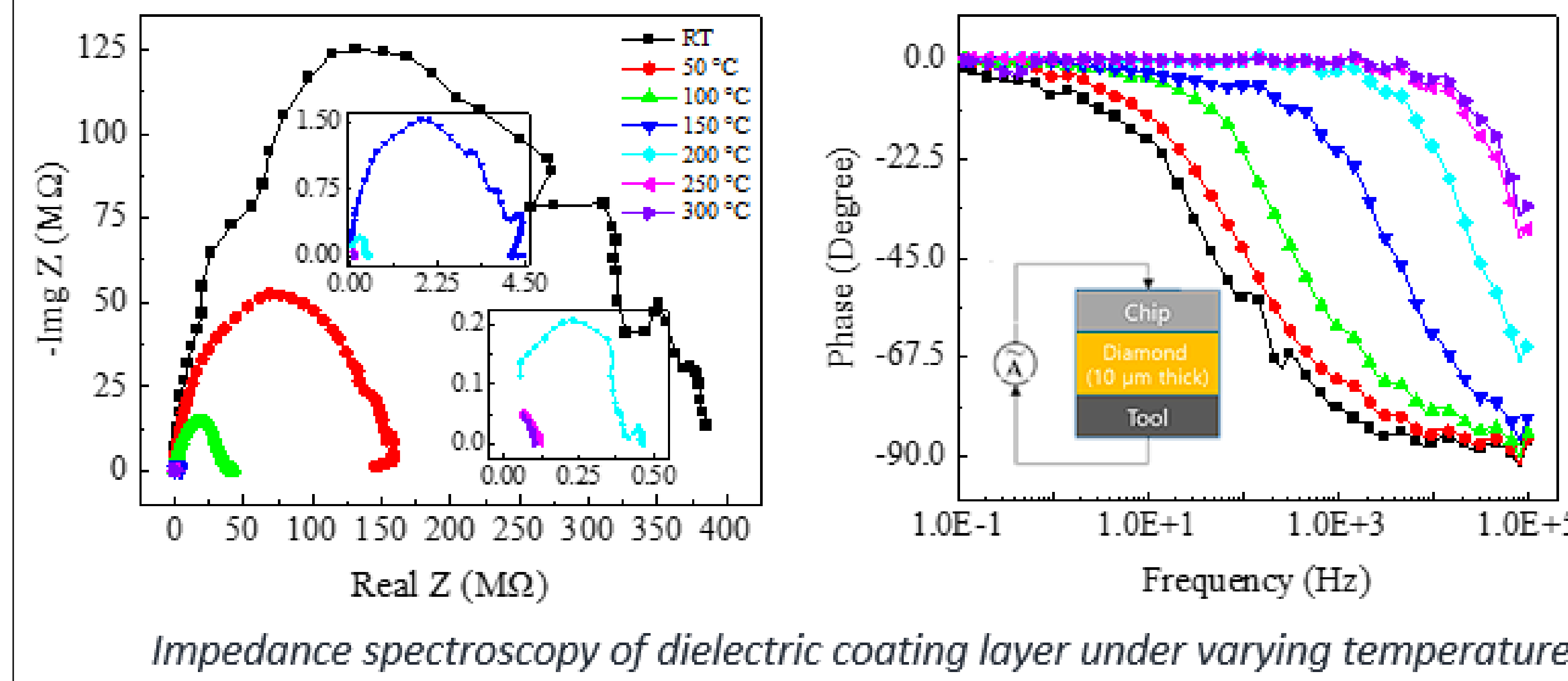
Abstract & Motivation

- Controlling and monitoring the machining process are critical for manufacturing efficiency.
- However, monitoring the region of the tool-chip interface (TCI) is challenging due to the physical inaccessibility.
- Currently, there are no tools available in the commercial market for measuring and monitoring cutting processes at the TCI region.
- The proposed method measures the real-time cutting temperature by directly probing the localized TCI using a cutting tool coated with dielectric material.
- The application and expectation of this study is to provide real-time machining data to help end users in manufacturing industry to improve product quality, productivity, and prolonged lifespan of cutting tools.



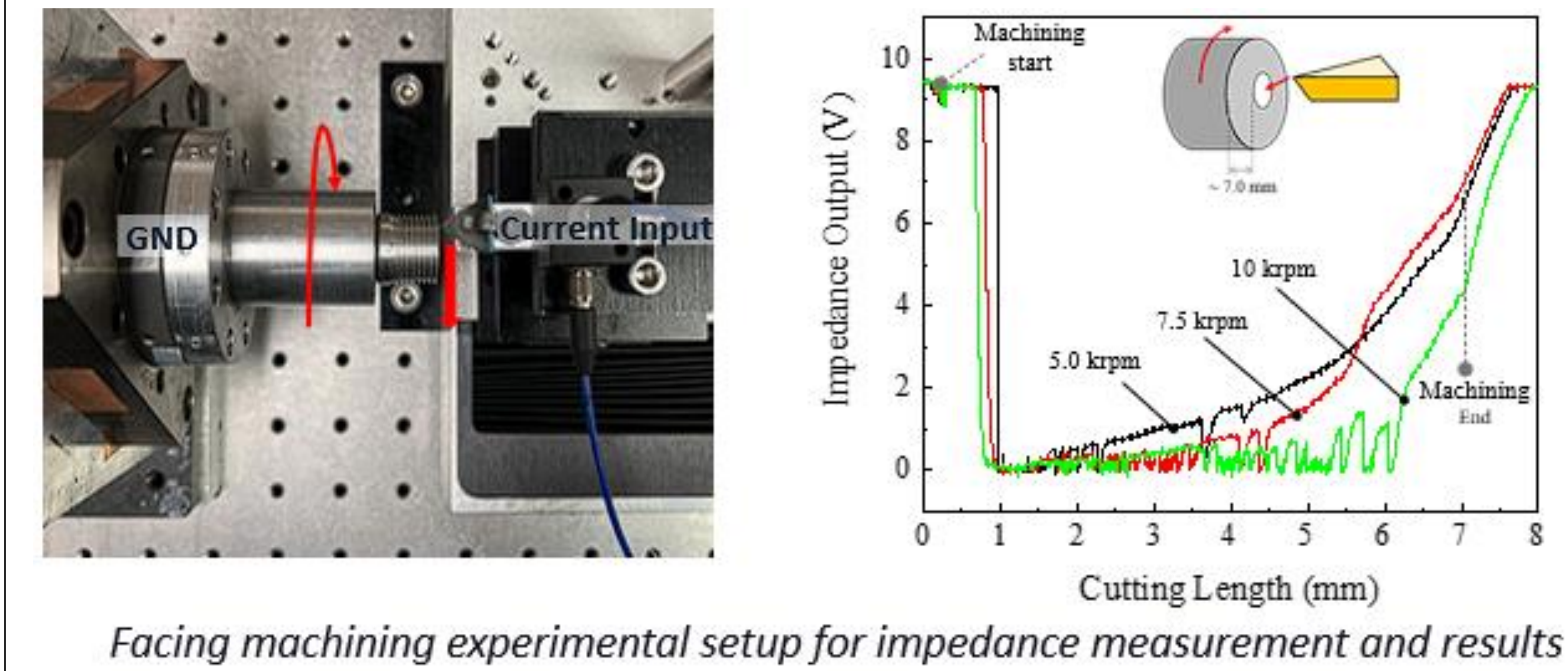
Impedance Analysis

- Impedance Spectroscopy (EIS): Diamond layer (contact area: $\sim 3.14\text{mm}^2$)
- Impedance **decreased** as temperature **increased**.
- Exhibited 1st order system response and natural frequency increased.
- Thus, the temperature-dependent impedance characteristic of dielectric could be utilized for the machining monitoring method to monitor the cutting temperature at the local TCI region.



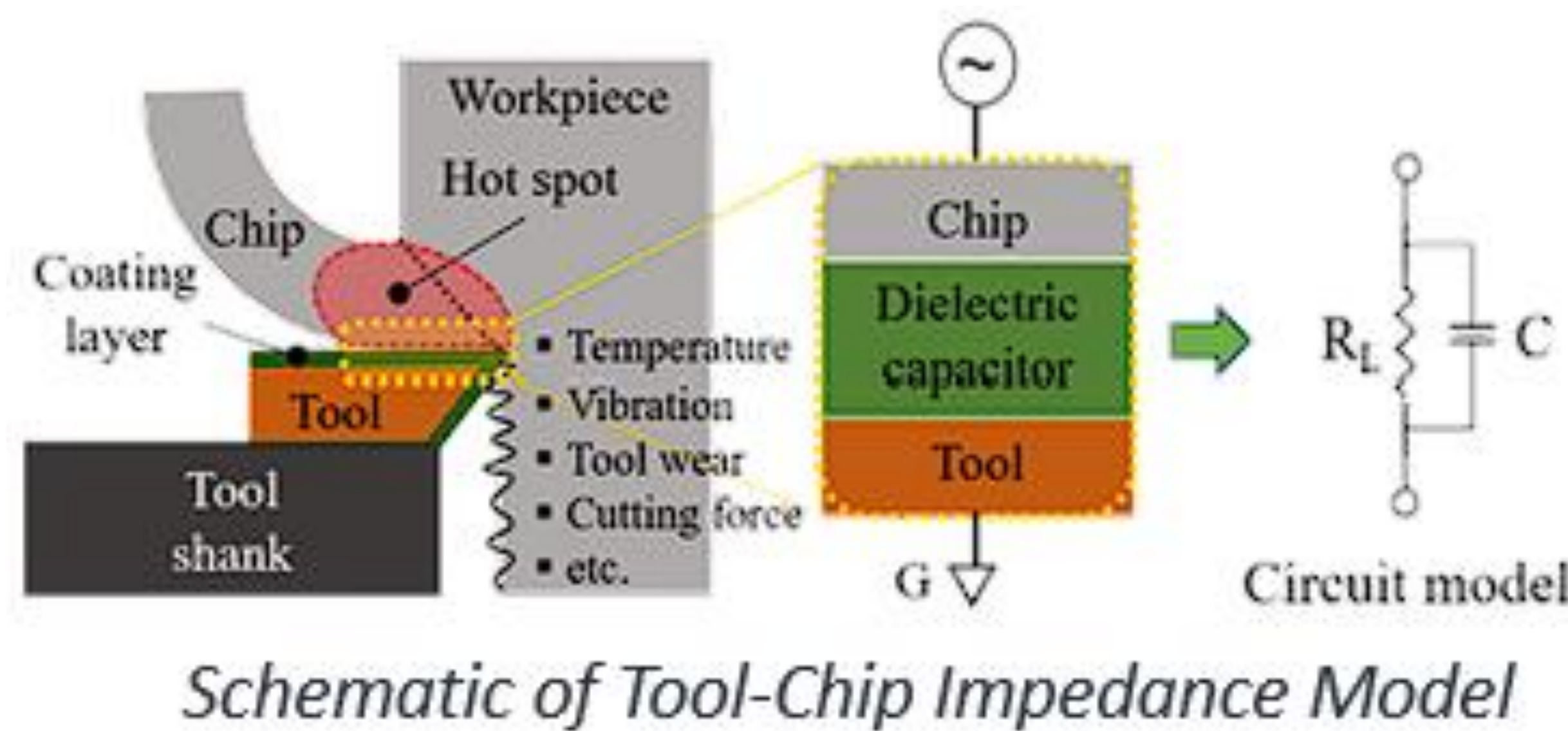
Machining Experiment

- Facing & Turning Operations performed
- Impedance at the TCI **dropped drastically** as machining started during facing operations and **showed different temperature profiles** for turning operations.



Methodology

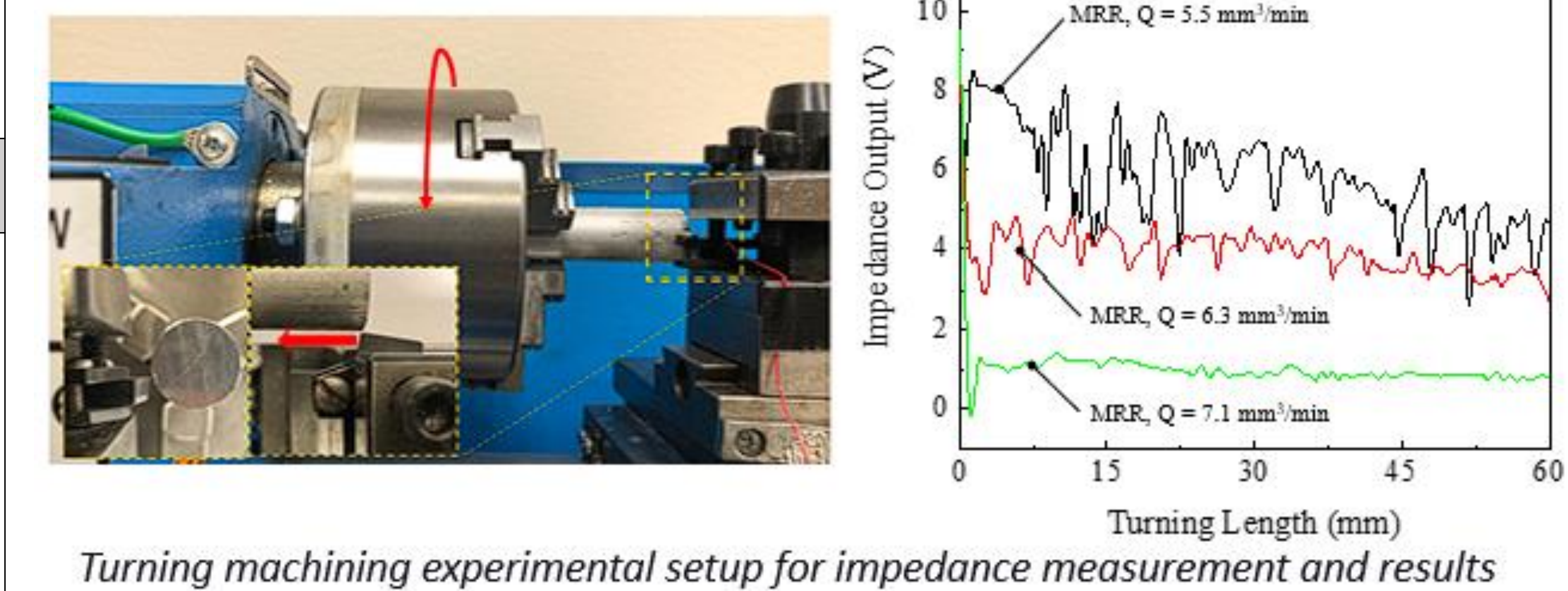
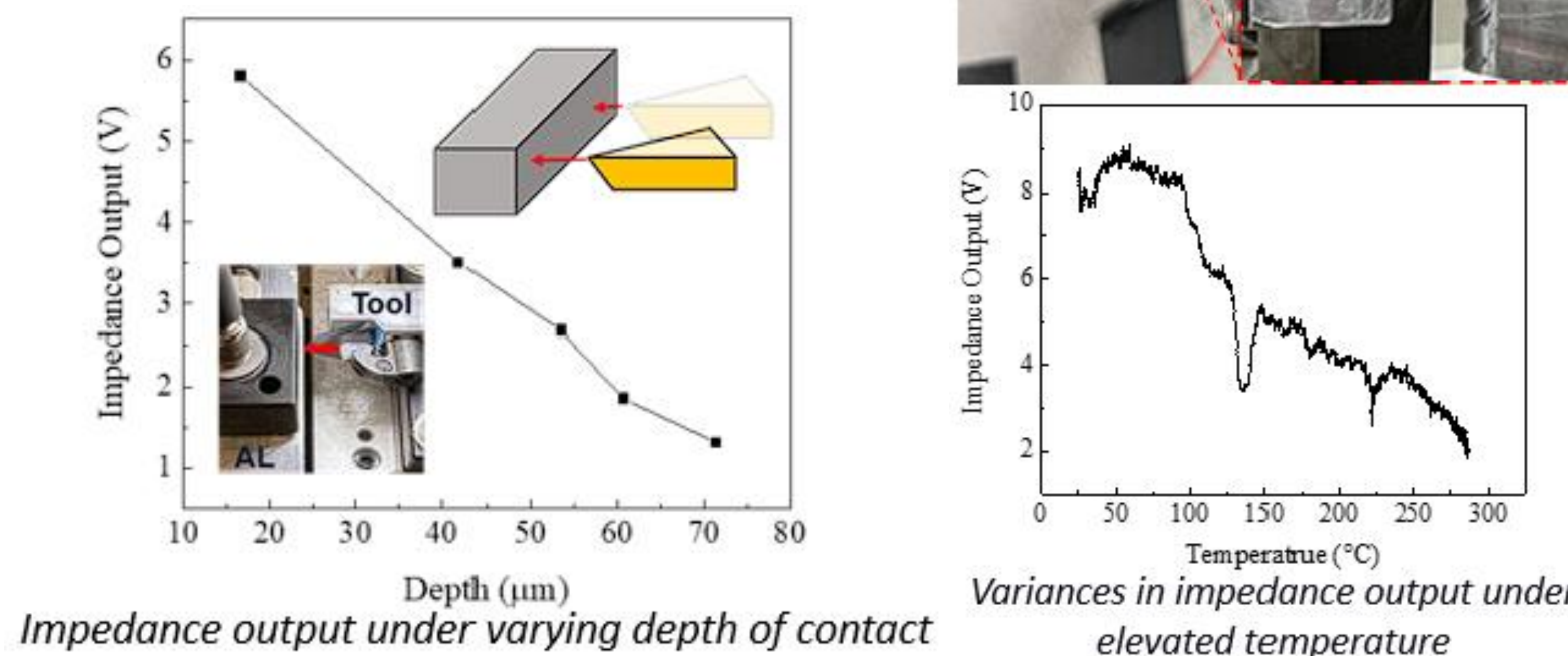
- Thin ($<100\mu\text{m}$) layer of coating are applied to the cutting tools to prevent tool wear and prolong the lifespan.
- Sandwiched tool structure is constructed while machining as shown in the below figure.
- Workpiece and base material (tool) » Electrodes
- Diamond coating » Dielectric capacitor
- Equivalent impedance is subject to change under varying temperature, contact area, and thickness of the dielectric material.
- Therefore, cutting temperature, vibration, tool wear, cutting force at the local TCI may be monitored.



Indentation & Heat Effects

- Impedance Output vs. Depth of Contact
- Tool was contacted under varying depth conditions and the output voltage was monitored. As the depth of contact **increased**, the output impedance **decreased**.

- Impedance of dielectric layer was monitored while increasing temperature. As **temperature raised**, output impedance **dropped significantly**.



Conclusion

- Preliminary study of the impedance model based in-process machining process monitoring method was introduced
- Impedance spectroscopy showed that the impedance of the dielectric coating layer was **dependent on temperature**
- Machining experiments were conducted, and the method exhibited the **capability of monitoring the machining process**
- Impedance of the dielectric layer was also **dependent on the contact area**
- Preliminary study results showed that the method can be applied to the machining process monitoring method

Future Works

- Relationship among impedance, temperature, contact area will be numerically and quantitatively analyzed throughout calibrations and characterization process
- Various cutting mechanics and machining processes will be assessed and monitored
- Other dielectric coating materials and different workpiece materials will also be considered after characterizing the impedance model.



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